## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KIJIMA et al.

Group Art Unit: 1773

Application No.:

10/724,635

Examiner:

Filed: December 2, 2003

Docket No.: 117926

For:

METHOD OF MANUFACTURING OXIDE THIN FILM, METHOD OF

MANUFACTURING FERROELECTRIC THIN FILM, FERROELECTRIC THIN FILM, FERROELECTRIC MEMORY DEVICE, AND FERROELECTRIC PIEZOELECTRIC

**DEVICE** 

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- $\bowtie$ This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- $\boxtimes$ 2. The references were cited in a counterpart foreign application. An English language version of the Chinese search report is attached for the Examiner's information.
- $\boxtimes$ In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent 3. application publications are not attached.
- $\boxtimes$ An English language Abstract of the non-English language reference is attached hereto. See Reference No. 2.

 $\boxtimes$ 

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5. U.S. Patent No. 6,541,278 (Reference No. 1) is the U.S. equivalent of CN 1264159 (Reference No. 2). Therefore, a copy of this reference is not submitted.

Respectfully submitted,

James A. Oliff

Registration No. 27,075

Thomas J. Pardini

Registration No. 30,411

JAO:TJP/fpw

Date: October 24, 2005

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
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Form PTO-1449 US Dept. of Commerce (REV. 8-83) PATENT & TRADEMARK OFFICE			ATTY DOCKET NO. 117926			APPLICATION NO. 10/724,635					
INFORMATION DISCLOSURE STATEMENT											
(Use several sheets if necessary)				APPLICANT(S) Takeshi KIJIMA et al.							
				FILING DATE December 2, 2003			GROUP 1773				
U.S. PATENT DOCUMENTS											
EXAMINER INITIAL		DOCUMENT NUMBER	I	DATE	NAM	ME		CLASS	SUB CLASS		
	1)	6,541,278	12-2	2003	MORITA et al.						
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		FOREIG	N PA	TENT DO	CUMENTS						
		DOCUMENT NUMBER	Ι	DATE	COUNT	ITRY		CLASS	SUB CLASS		
	2)	CN 1264159 (w/Abstract)	05-2	2000	CHINA	HINA		,			
				· -							
		OTHER DOCUMENTS (Incl	ludin	g Author,	 	es. etc.)					
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Examiner: In	itial if	citation considered, whether or not citation and not considered. Include copy of	ation	is in con	formance with M.P.E.P.	609; draw	line th	rough citation	on if not in		

Date: October 24, 2005